



PATENTS
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GF 2764

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re The Application of:)
Maria E. Barone et al.)
Serial No.: 09/033,997)
Filed: March 3, 1998)
For: Method and Apparatus for Predicting)
Plasma-Process Surface Profiles)

Examiner: Not Yet Assigned

Art Unit: 2764

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Sir:

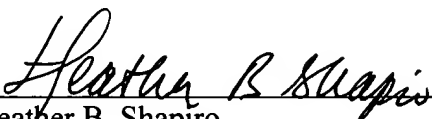
INFORMATION-DISCLOSURE STATEMENT

In keeping with the duty of candor and good faith owed to the Patent and Trade-mark Office, Applicants wish to bring to the Examiner's attention the references listed on the accompanying form PTO-1449. A copy of each listed reference is enclosed.

The undersigned hereby certifies that each item contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

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Respectfully submitted,


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